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				Application Number	10/581,497
				Filing Date	June 2, 2006
				First Named Inventor	Babak HEIDARI
				Art Unit	1791
				Examiner Name	Stephen J. SOLLENBERGER
Sheet	1	of	1	Attorney Docket Number	02386.0105

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite No. ¹	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
/DNB II/		US 4,844,947	07/04/1989	Kasner et al.	
/DNB II/		US 6,027,630	02/22/2000	Cohen	
/DNB II/		US 6,284,345	09/04/2001	Ruoff	
/DNB II/		US 7,374,864	05/20/2008	Guo et al.	
/DNB II/		US 2004/0079730	04/29/2004	Ahrens et al.	

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FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation ⁶
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/DNB II/		JP 2000-194142	07-14-2000	Fujitsu Ltd		Abstract

NONPATENT LITERATURE DOCUMENTS			
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/DNB II/		WISSEN et al., "UV CURING OF RESISTS FOR WARM EMBOSsing", Elsevier B.V., Microelectronic Engineering, Vol. 73-74, pp. 184-187, (2004).	
/DNB II/		REANO et al., "STABILITY OF FUNCTIONAL POLYMERS AFTER PLASTICIZER-ASSISTED IMPRINT LITHOGRAPHY", Journal of Vacuum Science & Technology, American Vacuum Society, Vol. 22, No. 6, pp. 3294-3299, (2004).	
/DNB II/		BENDER et al., "FABRICATION OF NANOSTRUCTURES USING A UV-BASED IMPRINT TECHNIQUE", Elsevier B.V., Microelectronic Engineering, Vol. 53, pp. 233-236, (2000).	
Examiner Signature	/David Brown II/		Date Considered

04/30/2010

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